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FEB 10 2004

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TC 1700

February 2, 2004

Mr. Yoshihide Nakamura
Senior General Manager
Intellectual Property Division
Sony Corporation
Osaki East Technology Center
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Shinagawa-ku, Tokyo
141-0032 Japan

Re: U.S. Patent Application of Satoshi TOMIOKA
For: METHOD OF PRODUCING SUBSTRATE
Application No.: 09/842,022; Filed: April 26, 2001
Your Reference No. S01P0532US00
Our Reference No. SON-2077 Our File No. 80001.2077

Dear Mr. Nakamura:

Thank you for your letter of January 28, 2004 approving the draft amendment in connection with the above-identified application. We prepared and filed the Amendment in Response to the Non-Final Office Action on February 2, 2004. A copy of each of the papers, as filed, are enclosed for your records.

We will keep you apprised of developments in this case as they occur. In the meantime, if you have any questions, please contact us.

Very truly yours,

RADER, FISHMAN & GRAUER PLLC

Ronald P. Kananen

RPK/LC/cdr
Enclosure